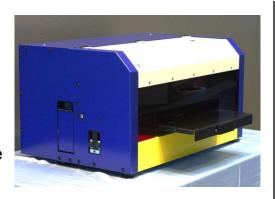
SMART Printer

- For resist mask and circuit printing
- ◆ High speed print (240 sec / A4 size)
- Easy usage

Only 3 operations to finish printing
Reduce 80% of conventional process time
Just 1 min to refill the ink tank





Features

- ◆Nozzle clogging is reduced by using the specified inkjet ink.
- ◆Since a UV LED curing system is built into the printer, printing and curing of the resist material can be realized simultaneously.
- ◆Our unique approach for ease-of-use ensures easy refilling of ink and replacement of print head.
- ◆ By replacing the print head, the SMART Printer can be used for either resist mask fabrication or conductive circuit fabrication.



Example Applications

Resist mask fabrication

- ◆Mask printing on glass substrates and optical components
- ◆Insulation pattern printing on electrical components.
- ◆Etch-mask printing on copper-laminated substrates and flexible copper-films. A circuit substrate can be created by etching after printing.

Electrical circuit fabrication

◆Silver nano ink printing on PET film and PI film.

A conductive circuit can be created by sintering 120 degrees after printing.



Specification

Specification	SMART printer (SMP-3021)
Print mechanism	Piezo inkjet (Minimum line width = 100μm, Depending on conditions)
Print data format	1-bit bitmap (BMP)
Available substrate size	300 mm(W) x 210 mm(D) x 0.8-30 mm(H)
Print speed	100 mm/sec, 250 mm/sec (selectable)
Fixing substrate	Adhesive or Vacuum stage
Required PC interface	USB2.0 x 1 (Windows7/10, 32bit / 64bit)
Body size	Approx. 600 mm(W) x 350 mm(D) x 330 mm(H)
Power consumption	< 100 W



ress

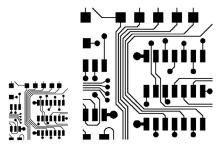
5-9-5 Tokodai, Tsukuba, Ibaraki 300-2635, Japan

Printing process

Step 1. Prepare print data (BMP image)

Convert DXF, Gerber, PDF data to BMP data using editing software (DFM Inkjet, etc.).





Binary BMP data

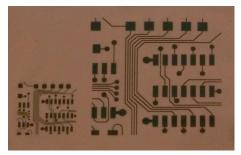
Step 2. Print

Operate the printer from PC

Just set the substrate and press the print button.

***When printing resist material, UV irradiation is performed inside the printer.**

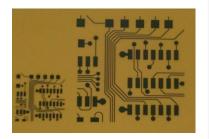




After print

Resist mask fabrication (Etching mask fabrication)

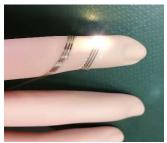
Step 3. Etching



Electrical circuit fabrication

Step 3. Sintering process (120 degrees 60 minutes)





Case)

Substrate: PET film Line width: 500µm Space: 400µm

Step 4. Remove resist material



Case)

Substrate: Cu-coated PI Line width: 200µm Space: 50µm